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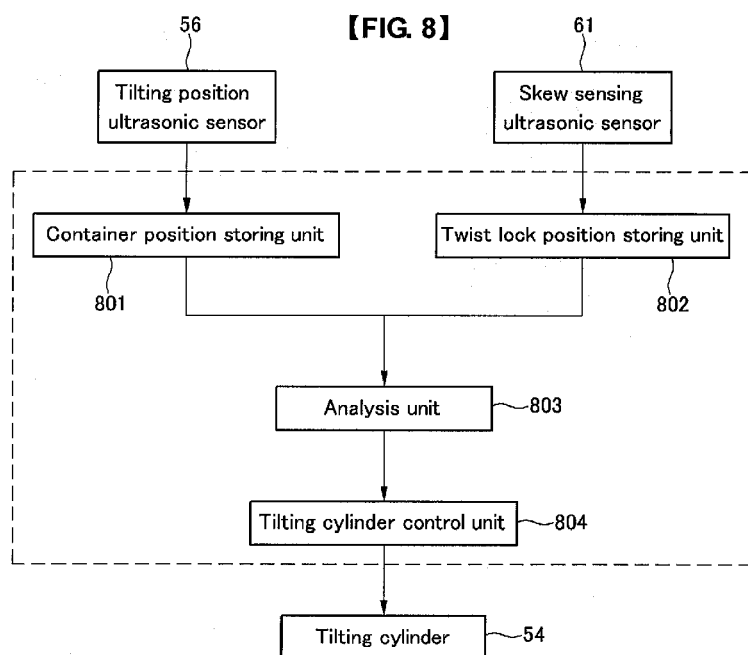
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(54) Title: APPARATUS FOR HANDLING CONTAINER AND SKEW RESISTANCE SYSTEM THEREOF



(57) Abstract: The present invention provides an apparatus for handling a container that has an improved structure of an upper arm of an apparatus for handling a container, and a skew resistance system thereof. The skew sensing system includes an improved upper arm, a skew sensing ultrasonic sensor that senses the skew of a container, and a tilting control device that calculates and adjusts the position of a twist lock. The upper arm includes a twist lock that fixes a container during pick-up, a tilting position ultrasonic sensor that senses the position of the twist lock, and a tilting cylinder that adjusts the position of the twist lock to left and right sides. Even if skew is generated due to poor alignment between a self-loading/unloading vehicle and a container, the skew sensing system allows the self-loading/unloading of a container to be stably performed by adjusting the position of the twist lock.